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Bib Data Sheet

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SERIAL NUMBER 09/976,739	FILING DATE 10/11/2001 RULE	CLASS 382	GROUP ART UNIT 2621	ATTORNEY DOCKET NO. TT4314
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## APPLICANTS

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\*\* CONTINUING DATA *VS* 08/18/04

\*\* FOREIGN APPLICATIONS *LS*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 11/14/2001

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no		
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		
Verified and Acknowledged	<i>John W. Dover</i> <i>LS</i> Examiner's Signature Initials		
STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
TX	2	20	3

## ADDRESS

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## TITLE

Method for evaluating anomalies in a semiconductor manufacturing process

FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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